

Electronic Acknowledgement Receipt

EFS ID:	1388422
Application Number:	10561802
International Application Number:	
Confirmation Number:	1118
Title of Invention:	Developer composition for resists and method for formation of resist pattern
First Named Inventor/Applicant Name:	Yasushi Washio
Customer Number:	20995
Filer:	Neil S. Bartfeld/Glen Martell
Filer Authorized By:	Neil S. Bartfeld
Attorney Docket Number:	SHIGA7.35APC
Receipt Date:	20-DEC-2006
Filing Date:	22-DEC-2005
Time Stamp:	14:18:08
Application Type:	U.S. National Stage under 35 USC 371

Payment information:

Submitted with Payment	no
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1		SHIGA7_035APC.pdf	233259	yes	5

Multipart Description/PDF files in .zip description			
Document Description	Start	End	
Amendment - After Non-Final Rejection	1	1	
Claims	2	2	
Applicant Arguments/Remarks Made in an Amendment	3	5	

Warnings:	
Information:	
Total Files Size (in bytes):	233259

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New Applications Under 35 U.S.C. 111
If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371
If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.